

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/620,184  
Applicant : Mitsuru Ozono, et al.  
Filed : July 15, 2003  
Patent No. : US 7,632,374 B2  
Issue Date : December 15, 2009  
Title : METHOD AND APPARATUS FOR PICKING UP  
SEMICONDUCTOR CHIP AND SUCTION AND  
EXFOLIATION TOOL USED THEREFOR  
  
Conf. No. : 8698  
TC/A.U. : 1734  
Examiner : Mark A. Osele  
  
Customer No. : 00116  
Docket No. : NGB-35857

**LETTER REGARDING PATENT PRINTING ERRORS**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In proofreading the referenced patent, typographical errors were noted. It is not believed that these errors require a Certificate of Correction. However, it is respectfully requested that this letter be placed in the file for this case.

The following errors were noted:

In column 6, line 5, please delete the space between the words “exfoliat” and “ion” to form the word -exfoliation-.

Respectfully submitted,  
PEARNE & GORDON LLP

\_\_\_\_\_/jeffrey j sopko/  
Jeffrey J. Sopko, Reg. No. 27676

1801 East 9<sup>th</sup> Street  
Suite 1200  
Cleveland, OH 44114

DATE: January 19, 2010